



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Zahorik et al.

Serial No.: 10/647,634

Filed: August 25, 2003

For: METHODS FOR SELECTIVE
REMOVAL OF MATERIAL FROM
WAFER ALIGNMENT MARKS

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Examiner: L. Vinh

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AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

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Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

Amendments to the specification begin on page 3 of this paper;

A listing of the claims begins on page 6 of this paper;

Corrections to the drawings are summarized on page 10 of this paper, with a replacement sheet and an annotated sheet showing the corrections enclosed herewith; and

Remarks start at page 11 of this paper.